

Standard recipe

PECVD

SiO<sub>2</sub>

<b>Material</b>	<b>N<sub>2</sub>O</b>	<b>N<sub>2</sub></b>	<b>SiH<sub>4</sub></b>	<b>Pressure</b>	<b>Power</b>	<b>Rate (nm/min)</b>	<b>Table Temp</b>
SiO <sub>2</sub>	710	161	9	650	20	40	300